

Status of the He⁺ Test Injector

O. Meusel, J. Pozimski, A. Bechtold, A. Schempp, U. Ratzinger

Riezlern 2004



Layout of the He+ Test injector







Layout of the LEBT - Section





radial enclosure condition

charge carrier in a magnetic field equation of motion:

$$m_e \frac{dv}{dt} = -e \cdot (E_{space} + v \times B)$$

angular velocity

$$\Theta' = -\frac{eB_z}{2m_e} + \frac{c}{r^2}$$

maximum density

$$E(r) = \frac{1}{\varepsilon_0 r} \int_0^r \rho_{\max}(r') r' dr$$

elementary charge $\rho_{e,\max,rad} = \frac{e\varepsilon_0}{2}$ magnetic field Bz permittivity of free space ϵ_{0} $\rho_{\text{e,max,rad}}$ electron density 2melectron mass m

simple assumption $\Phi(r=0) = 0$ ΦŶ for homogeneous charge carrier distribution the maximum density is given by: tial free space $\rho_{e,m}$ ity

longitudinal enclosure condition

$$\max_{Aax,long} = \frac{4U_A \varepsilon_0}{r_A^2} \qquad \begin{cases} U_A & \text{anode potent} \\ \varepsilon_0 & \text{permittivity of } \\ \rho_{e,maxlong} & \text{electron densitivity of } \\ r_A & \text{anode radius} \end{cases}$$

Beam Transport Measurement using Lens 1 W = 14 keV, I = 9 mA

Beam Transport Measurement using Lens 1 & 2 W = 14 keV, I = 9 mA $\epsilon_{n,rms,100\%}$ =0,062 π mmmrad $\epsilon_{n,rms,100\%}$ =0,022 π mmmrad $\epsilon_{n.rms,100\%}$ =0,036 π mmmrad 100 X' [mrad] X' [mrad] ([mrad] > -10 10 -20 -1020 -20 -10 10 × [mm] × [mm] 0 .× [mm] 24 22 20 $\frac{1}{f} = \frac{n_e \cdot e}{4 \cdot \varepsilon_0 \cdot U_B} \cdot l$ 18 16 14 [mm] 12 $\kappa_r = \frac{n_{\text{exp}}}{n_r} \quad \kappa_l = \frac{n_{\text{exp}}}{n_l}$ 10 8 lens parameters: lens parameters: 6 $\kappa_r = 49\%$ $\kappa_l = 61\%$ $B_{z,max} = 66 \text{ mT}$ $B_{z,max} = 77 \text{ mT}$ 4 $\Phi_{Anode,maxl}$ = 1850 V $\Phi_{Anode,maxl}$ = 2600 V 2 0 300 600 0 100 200 400 500 700 z [mm] Lens2 1e+15 Space charge density distribution 8e+14 Ш 6e+14 [m_³] ⊆[≏] 4e+14 2e+14 0 m⁻³ 2,1e14 m⁻³ 0e+0 0 5 10 15 20 25 30

r [mm]

in Zusammenarbeit mit der AG Schempp Four - Rod - RFQ

3,5 keV/u 110 keV/u 80 kV 0,7 mA A/q 33 % 16

108,48 MHz

Eingangsenergie:
Ausgangsenergie:
Elektrodenspannung:
Strahlstrom:
Tastverhältnis:
Masse/Ladung:
Betriebsfrequenz:

Beam Diagnostic behind the RFQ

Beam Transport Simulations using PARMTEQ

Optical Profile Measurement

P = 7kW

P=8kW

integrated opt. beam profile 1,5e+9 1,3e+9 Σ Intensity [a.u.] 1,0e+9 7,5e+8 5,0e+8 2,5e+8 0,0e+0 2 0 1 3 5 6 7 8 9 10 4 P [kW]

Energy Spectroscopy

 $P_{RFQ} = 8 \text{ kW}$

Plan for the near future

- Optimisation of the beam matching into the RFQ
 - Measurement of the beam properties in y plane
 - Measurement of the time structure of the beam properties
 - Installation of a large Gabor lens behind the RFQ
 - Beam focussing into a target chamber